



JUN 18 2004

PTO/SB/08A (06-03)

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet

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of

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Complete If Known

Application Number	09/970,453
Filing Date	October 2, 2001
First Named Inventor	Eyal, Shulermit
Art Unit	1841
Examiner Name	Cook, Lisa V.
Attorney Docket Number	20174C-002410US

U.S. PATENT DOCUMENTS+

Examiner Initials*	Document Number Cite No. ¹	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Page, Column, Line, Relevant Passages or Relevant Figures Appear
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Examiner Signature

Lisa V. Cook

Date Considered

1/11/05

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Information Disclosure Statement by Applicant <i>(use as many sheets as necessary)</i>		Complete If Known	
Sheet	2	of	8
		Application Number	09/970,453
		Filing Date	October 2, 2001
		First Named Inventor	Eyal Shulamit
		Art Unit	1841
		Examiner Name	Cook, Lisa V.
		Attorney Docket Number	2017AC-002410US

U.S. PATENT DOCUMENTS*				
	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
Examiner Initials*	Cite No.	Number Kind Code* (If Known)		Pages, Column, Lines, Where Relevant Passages or Relevant Figures Appear
L/C	A42	US-6,123,769	09-25-2000	Sanjoh
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Examiner Initials*	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Page, Column, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³	Number ⁴	Kind Code ⁵ (Eaton)		
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	B2	EPO	EP 0 703 384	A1	03-27-1998	
LYC	B3	EPO	EP 0 706 004	A2	04-10-1998	
	B4	EPO	EP 0 779 438	A2	06-18-1997	
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LYC	B12	PCT	WO 00/03045	A1	10-12-2000	

Examiner Signature	Risa Clark	Date Considered	1/11/05
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Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 801.04.² Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3).³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.⁴ Kind of document by patent document symbols as indicated in the document under WIPO Standard ST. 16 if possible.⁵ Applicant is to



Substitute for form 1449B/PTO				<i>Complete if Known</i>	
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				Art Unit	1641
				Examiner Name	Cook, Lisa V.
				Attorney Docket Number	20174C-002410US
Sheet	3	of	8		

NON PATENT LITERATURE DOCUMENTS					
. Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²
L/C	C1	"Acousto-Optic Modulators" available at www.brimrose.com/acousto_modulators.html , 9-27-2000			
	C2	AHN et al., "Fluid Micropumps Based on Rotary Magnetic Actuators," Proceedings of 1995 IEEE Micro-Electro Mechanical Systems Workshop (MEMS '95), held in Amsterdam, Netherlands on 1/25-2/2/1995, pgs. 408-412.			
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Examiner Signature	<i>Lisa Cook</i>	Date Considered	1/11/05
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(use as many sheets as necessary)

			Complete if Known
Application Number	09/970,453		
Filing Date	October 2, 2001		
First Named Inventor	Eyal, Shulamit		
Art Unit	1641		
Examiner Name	Cook, Lisa V.		
Sheet	4	of	8
		Attorney Docket Number	20174C-002410US

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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Examiner Signature	Lisa V. Cook	Date Considered	11/11/05
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(use as many sheets as necessary)			
Sheet	5	of	8
Complete if Known			
Application Number 09/970,453			
Filing Date October 2, 2001			
First Named Inventor Eyal, Shulamit			
Art Unit 1641			
Examiner Name Cook, Lisa V.			
Attorney Docket Number 20174C-002410US			

NON PATENT LITERATURE DOCUMENTS			
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Examiner Signature	<i>Lisa Cook</i>	Date Considered	1/11/05
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Sheet

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Application Number	09/970,453
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LVC	C37	PETHIG & MARKX "Applications of dielectrophoresis in biotechnology," Tibtech, 15:428-432 (1997).	
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LVC	C50	VAN DE POL et al., "Micro Liquid Handling Devices - A Review", Micro Systems Technologies, 1990, pp. 799-805, Vol. 90.			
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LVC	C62	Zengerle et al., "Performance Simulation of Microminiaturized Membrane Pumps," from 7th International Conference on Solid-State Sensors and Actuators held 6/7-10/93 in Yokohama Japan, pages 106-109			T ²

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